



Patent
Attorney's Docket No. 015290-704

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of) **MAIL STOP AF**
Oinghong K. Gao et al.)
Application No.: 10/600,273) **Group Art Unit: 1763**
Filed: June 20, 2003) **Examiner: Rakesh Kumar Dhingra**
For: MULTIPLE ZONE GAS) **Confirmation No.: 6096**
DISTRIBUTION APPARATUS FOR)
THERMAL CONTROL OF)
SEMICONDUCTOR WAFER.)

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated October 4, 2005, please amend the above-identified patent application as follows:

2/01/2005 SZEWDIE1 00000063 10600273

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